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CONFIRMATION NO. 7155

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/587,394	07/27/2006	137	1792	294256US26PCT		
RULE						
APPLICANTS Shuuichi Ishizuka, Yamanashi, JAPAN; Masaru Sasaki, Hyogo, JAPAN; Tetsuro Takahashi, Yamanashi, JAPAN; Koji Maekawa, Yamanashi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/01057 01/27/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-020157 01/28/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/27/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /JOSEPH ALBERT MILLER, JR/ Acknowledged Examiner's Signature		Initials	JAPAN	7	20	4
ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES						
TITLE Method for cleaning process chamber of substrate processing apparatus, substrate processing apparatus, and method for processing substrate						
FILING FEE RECEIVED 1100	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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